

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

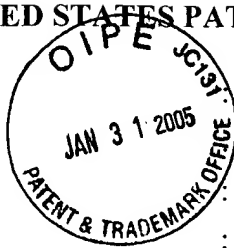
In re Patent Application of:

Raffaele ZAMBRANO

Serial No.: 09/191,743

Filed: November 13, 1998

For: IN-SITU DEPOSITION AND  
DOPING PROCESS FOR POLY-  
CRYSTALLINE SILICON LAYERS  
AND THE RESULTING DEVICE



Atty. Docket No.: 97-CT-174

Group Art Unit: 2823

Confirmation No.: 8970

Examiner: M. Estrada

TRANSMITTAL LETTER

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Notice of Allowance and Issue Fee mailed October 26, 2004, attached hereto are the following to complete the requirements in the above-identified application:

XX Issue Fee Transmittal (in duplicate)

XX Claim for Priority with certified copy of European Appl. No. 97 830 603.3

The Commissioner is authorized to charge any required fees or credit any overpayment to Deposit Account No. 50-1556.

Respectfully submitted,

Date:

1/21/05

By:

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450.

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1/25/05  
Date of Deposit